

FORM PTO-1449 (Modified)

SEP 07 2001

ATTY. DOCKET NO.

SERIAL NO.

YOR920000692US1

09/769,170

LIST OF PATENTS AND PUBLICATIONS
FOR APPLICANT'S INFORMATION
DISCLOSURE STATEMENT

APPLICANT: J.O. Chu et al.

(Use several sheets if necessary)

FILING DATE:
January 25, 2001

GROUP:
2811

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)
EH	AA	5,674,758	10/7/1997	McCarthy	437	21	06/06/1995
	AB	5,994,207	11/30/1999	Henley et al.	438	515	02/19/1998
	AC	5,528,397	06/18/1996	Zavracky et al.	359	59	07/28/1994
	AD	5,399,231	03/21/1995	McCarthy	156	630	10/18/1993
	AE	5,877,034	03/02/1999	Ramm et al.	438	15	09/22/1995
	AF	6,033,974	03/07/2000	Henley et al.	438	526	08/10/1999
	AG	5,876,497	03/02/1999	Atoji	117	85	12/09/1996
	AH	5,856,229	01/05/1999	Sakaguchi et al.	438	406	05/27/1997
	AI	5,882,987	03/16/1999	Srikrishnan	438	458	08/26/1997
	AJ	5,710,057	01/20/1998	Kenney	437	62	07/12/1996
	AK	5,374,564	12/20/1994	Bruel	437	24	09/15/1992
EH	AL	5,906,951	05/25/1999	Chu et al.	438	751	04/30/1997

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
EH	AM	96,264,386	6/20/1997	Japan				

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

EH	AN	K. Sakaguchi et al., "SOI Wafers Epitaxial Technology", Solid State Technology, June 2000, pp.88-92					
	AO						

EXAMINER

DATE CONSIDERED

12-10-02

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.